

# Present Status of Infrastructure Facilities for SCRF Cavity Development



**S C Joshi, S Raghavendra, A Bose, G V Kane, S K  
Suhane, S K Chauhan, S Kokil, A Puntambekar, N K  
Sharma and P D Gupta**  
***Raja Ramanna Centre for Advanced Technology,  
Indore, INDIA***

# Development of Superconducting Cavities and Associated Technologies for High Energy Accelerators and their Applications

## Objectives :

- Technology development and setting up of an infrastructure for the SCRF cavity fabrication, chemical processing, cleaning, assembly and testing at required accelerating gradient for accelerator applications
- To establish Cryogenic Infrastructure to operate large systems operating at liquid helium environment
- Experimental research in bulk and thin film superconducting materials for building accelerating cavities with high gradient and high quality factor

## New Facilities Planned at RRCAT

### SCRF cavity fabrication Facilities:

120 Ton Hydraulic Press, Nb machining, **EBW Machine** etc.

### Chemical & thermal processing facilities

EP/BCP/CBP, HPR & **Annealing Furnaces** etc.,

### Cavity Inspection Facilities

3-D CMM, UTM, Optical inspection bench, 3-D confocal microscope, SIMS

### Cavity RF Measurement & Tuning Facility

Half Cell, dumbell and multi-cell cavity frequency measurement

**Cavity Frequency & field tuning machine (under design)**

### Assembly & testing set up.

**Clean-room**, **Test cryostats**, RF sources etc.

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# Cavity Fabrication Facility

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# Development work done on Forming & Machining



Forming



Inspection



Machining



Formed Niobium Half cell

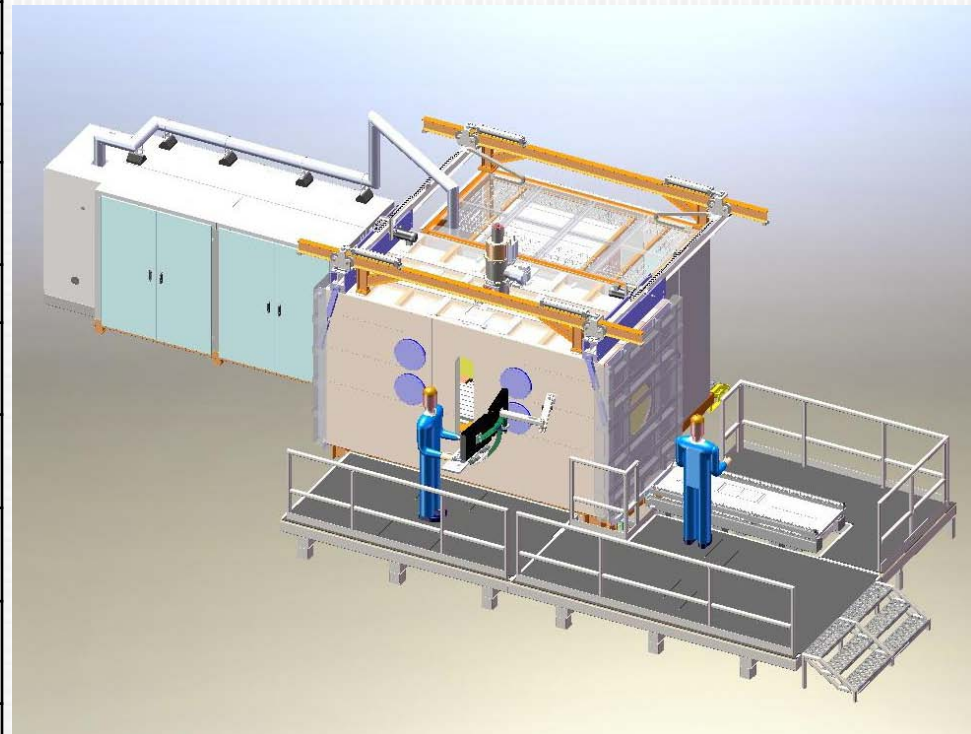
## 120 T – HYDRAULIC PRESS



## Electron Beam Welding Machine

### Major specifications of EBW Machine

Beam power	15 kW
Gun Voltage	90 to 150 kV
Duty cycle	100%
Beam current range	100 mA
Beam current setting resolution	0.1 mA
Beam oscillations	1 – 1000 Hz or more
Beam focus diameter	0.25 mm
Inner size of chamber	3650 x 1500 x 1800 mm <sup>3</sup>
X-Y table size	1780 m x 710 mm
Vacuum ready pressure	< 1x10 <sup>-4</sup> mbar in 15 min
Ready for welding pressure	< 1x10 <sup>-6</sup> mbar in 60 min



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# Inspection, Measurement & Cavity Test Facility

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# 3D CNC Coordinate Measuring Machine

## Applications :

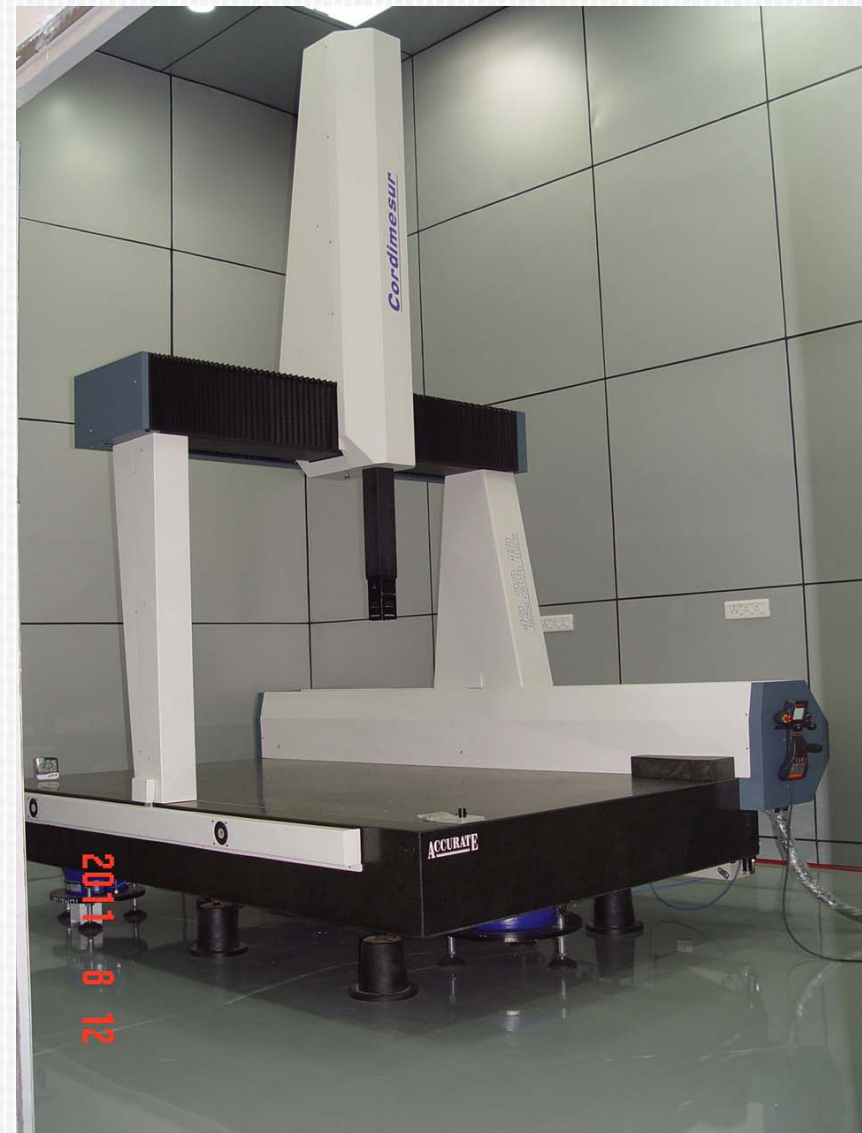
Dimensional inspection of SCRF cavity components like half cells, dumb-bells, multi-cells etc

## Accuracy :

$1.6 + L/400$  microns

## Commissioning :

In progress





# Universal testing machine for evaluation of mechanical properties

## Instron UTM Model: 5569

- ✗ Load:  $\pm 50$  kN
- ✗ Testing speed: 0.001 – 500 mm/min
- ✗ Accuracy of Load:  $\pm 0.5\%$  for 0.5 – 50 kN
- ✗ Strain measurement Accuracy: ASTM E 83 Class B or better
- ✗ Total cross head travel: 1500 mm

## Measurements:

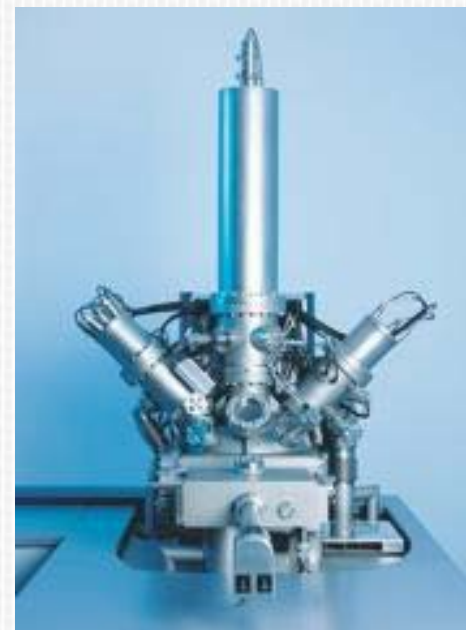
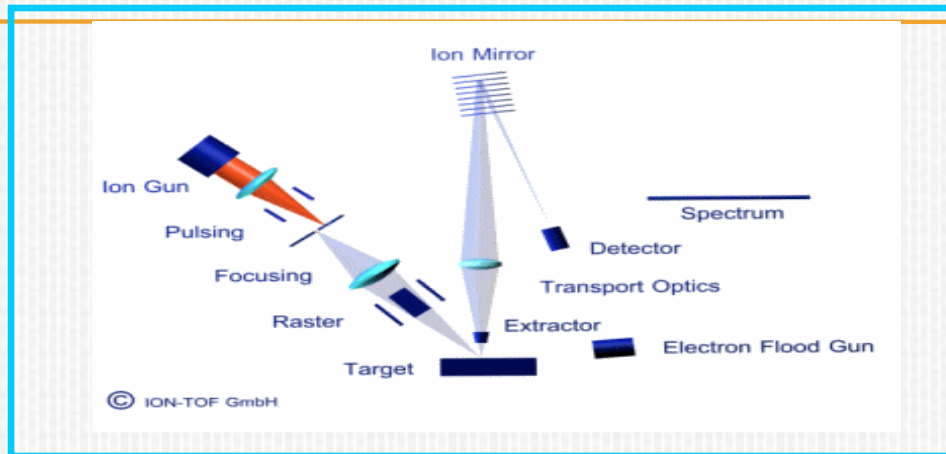
- Yield strength, ultimate tensile strength
- Elongation
- Plastic strain ratio, Strain hardening exponent.
- Cavity Stiffness measurement



## Secondary Ion Mass Spectrometer (SIMS)

To develop understanding of impurity distribution near the top layer (~100 - 200 nm) of niobium by 2-D, 3-D ion mapping of the impurities.

Quantification of the elemental impurity distribution using niobium standards .



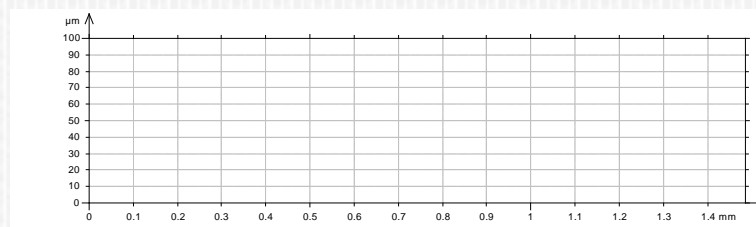
**SIMS has been commissioned Nov – 2011.**

# 3D Laser scanning confocal microscope

<b>Imaging Method</b>	3-D Laser Scanning Confocal system
<b>Z - Resolution (Depth)</b>	$\leq 10 \text{ nm}$
<b>Z - Measurement repeatability</b>	12 nm
<b>Z – measurement range</b>	10 mm
<b>X-Y Resolution</b>	$0.12 \text{ }\mu\text{m}$



Olympus LEXT OLS 4000 Laser scanning confocal microscope



# Cavity Optical Inspection

Cavity internal surface measurement using a small digital CCD camera with magnification 10X–200X



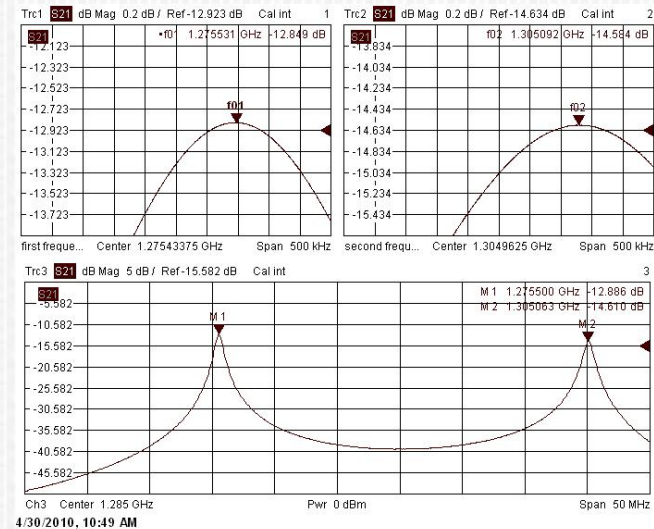
Motorized Optical inspection bench for cavity internal inspection for 1.3 GHz –9 cell SCRF cavity



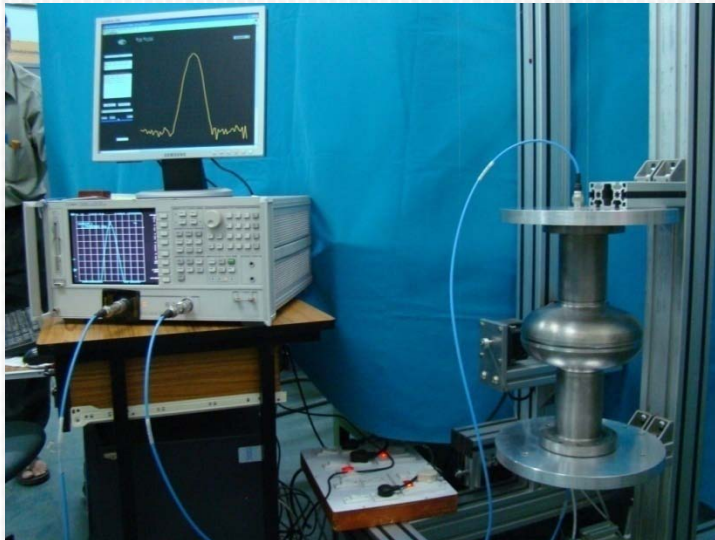




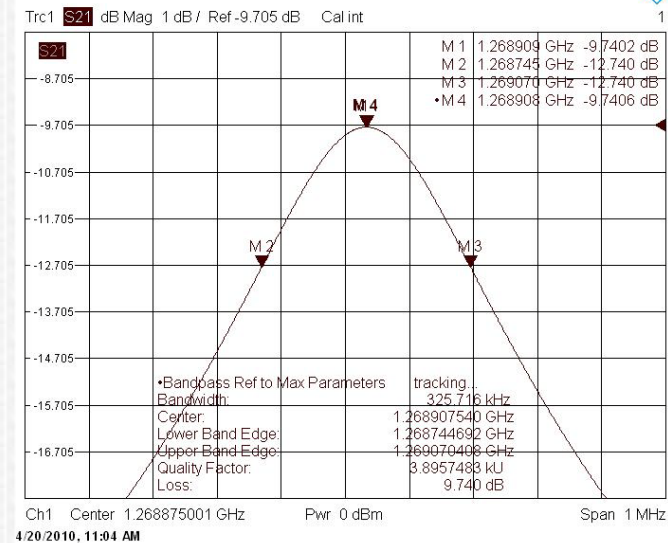
**RF FREQUENCY MEASUREMENT SETUP**



**RF FREQUENCY PEAKS OF DUMB-BELL**



**RF MEASUREMENT SET UP FOR FREQUENCY AND FIELD DISTRIBUTION**



**RF FREQUENCY PEAKS OF SINGLE CELL CAVITY**

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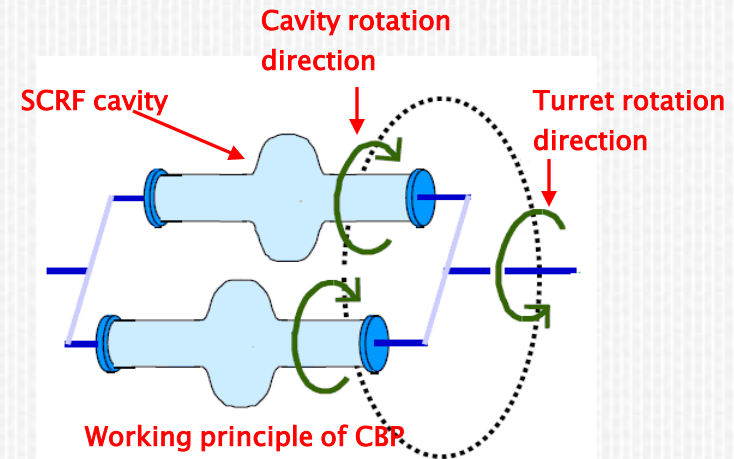
# Cavity processing facility

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## Centrifugal Barrel Polishing (single Cell)

### Main features of CBP machine

- ❖ Turret and Barrel rotate in opposite direction
- ❖ Turret speed – 0 – 200 rpm ( variable )
- ❖ Barrel speed – 0 – 200 rpm ( variable )
- ❖ Barrel size – 320 X 320 X 500 mm



Cavity ready for mounting in CBP m/c

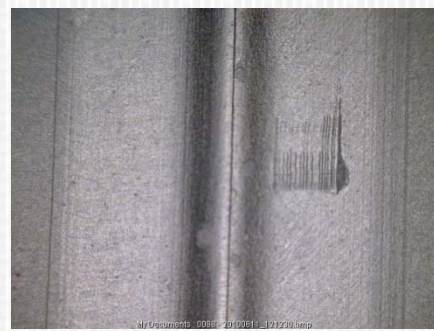


Cavities mounted in CBP machine

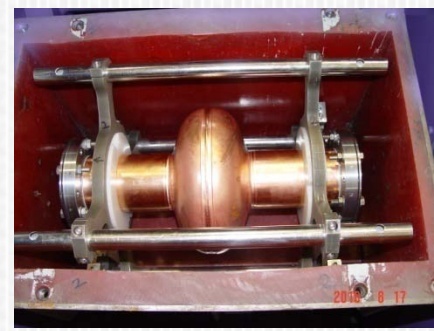


## Initial Trial Results of CBP

### ALUMINUM CAVITY



### COPPER CAVITY





# Ultrasonic cleaning facility



Ultrasonic cleaner for single cell cavity & small components



Ultrasonic cleaner for 9 cell cavities

## Development of Electro polishing setup

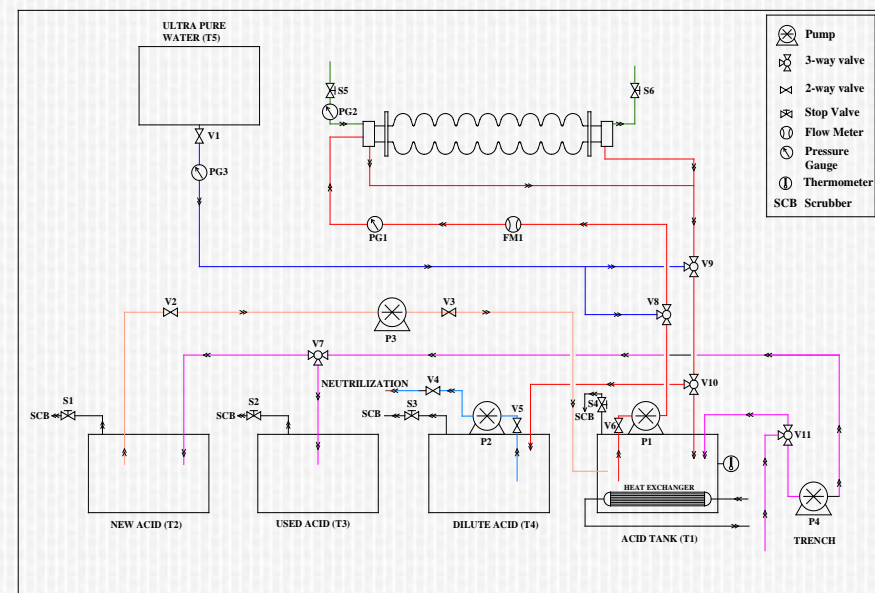
- Bench for electro-polishing of SCRF cavity has been developed, it can process 1.3 GHz –9 cell cavity.

The stand is capable of :

- Rotating the cavity at 2–10 rpm.
- Holding the cavity in horizontal position during processing & in vertical position during draining/ rinsing and for loading the cathode
- connect power supply using Slip ring with 4 carbon brushes

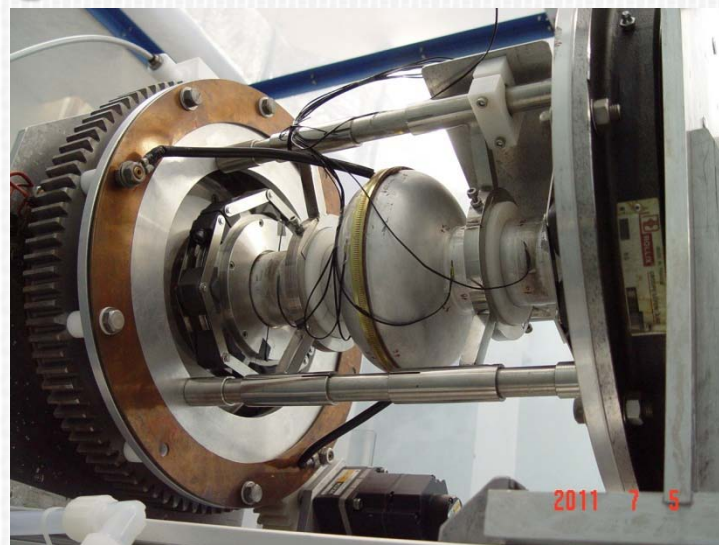
The flow circuit has been assembled and tested.

A 25V – 1000A DC Power supply has been procured.





# Electro-polishing of Single cell Aluminium cavity



After fabrication  
(without any  
processing)



After Barrel polishing



After 30 micron  
Electropolishing

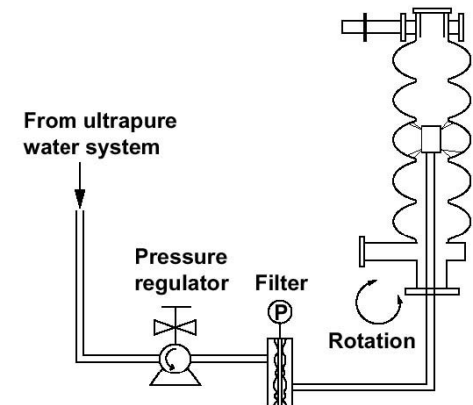
Surface roughness of 50nm was obtained in the beam pipe after electro-polishing

## Features:

- Cavity / wand Rotational speed: 2–20 RPM
- Vertical Stroke: 1300 mm
- Vertical movement speed: 60 mm/min
- Ultra-pure water jet. pressure: 80 – 100 bar



High Pressure Rinsing Set up in Clean enclosure (Class 100)



High Pressure Cleaning of dummy cavity

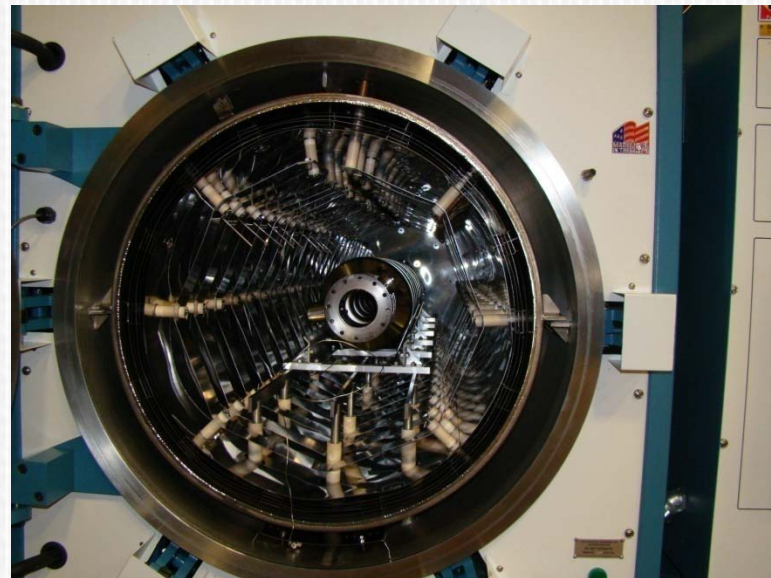
Ultra Pure Water Plant



## Specification of High Vacuum Furnace

<b>Orientation</b>	<b>Horizontal</b>
<b>Temperature range</b>	<b>1400°C Max</b>
<b>Working Vacuum</b>	<b>&lt;1 x 10<sup>-7</sup> mbar (600°C -1000°C ) &lt;1 x 10<sup>-6</sup> mbar (&gt; 1000°C)</b>
<b>Working Volume</b>	<b>Diameter 825mm Depth 1500mm</b>

The furnace is under procurement

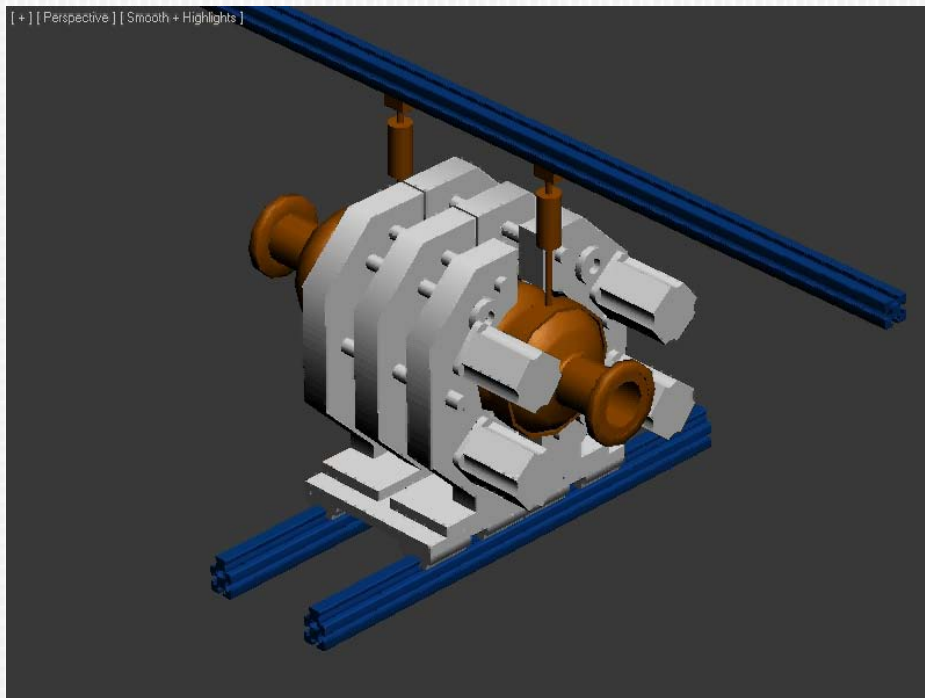
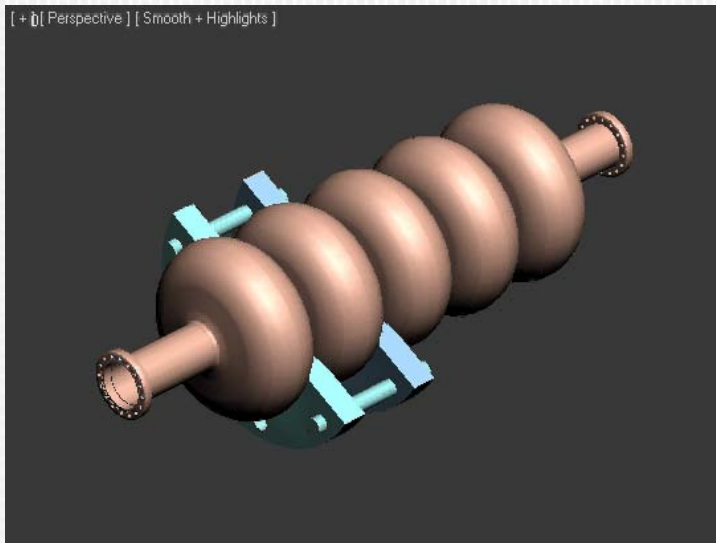


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# SCRF Cavity Tuning Machine

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# Tuning of SCRF Cavity



- A multicell elliptical accelerating cavity requires a “flat” electrical field profile at the target  $\pi$ -mode frequency
- $E_{min}/E_{max} > 0.98$
- ❖ Cavity requires cell to cell tuning due to shape deformation during fabrication, material removal at various stages of polishing & also deformation during thermal processing.
- ❖ Cavity must be straight & requires an alignment

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# Building to House SCRF Cavity Infrastructure Facility

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# Building for SCRF Cavity Development

## Cavity Fabrication, Assembly & Processing Building

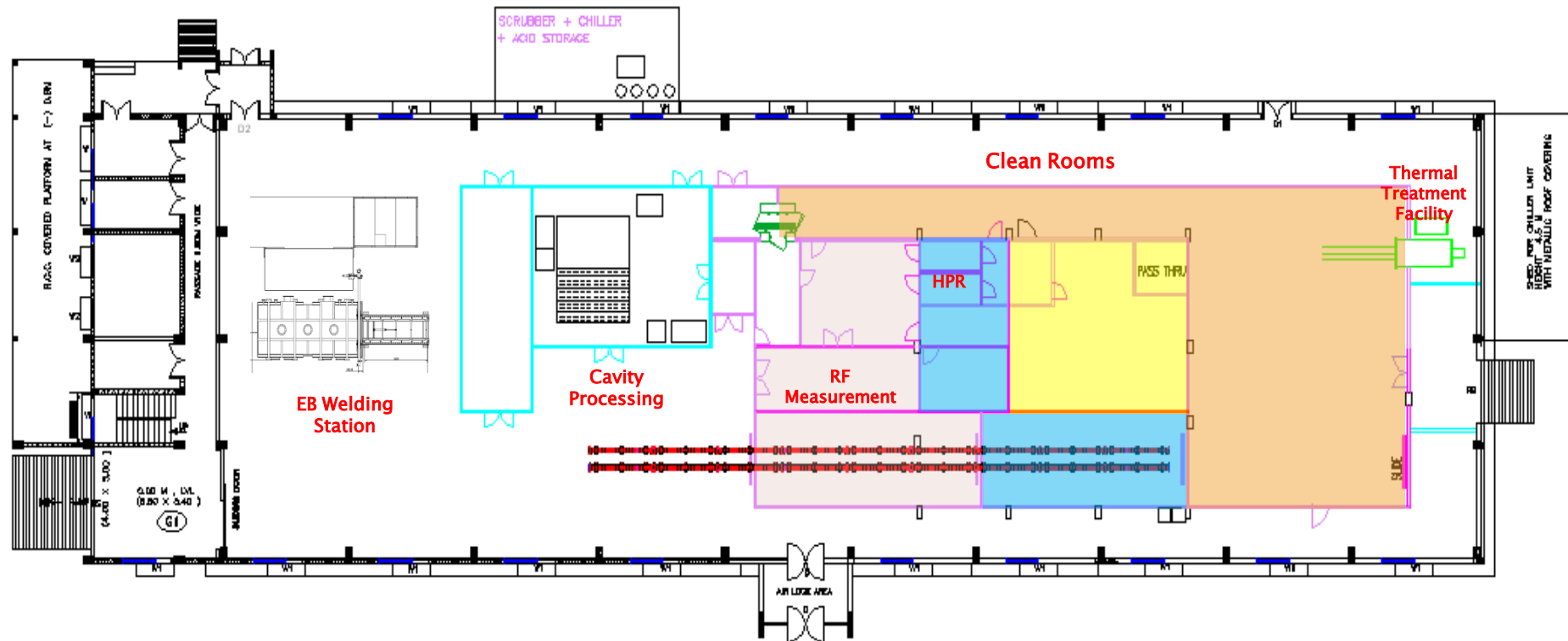
- The building will house clean rooms, Electron Beam welding machine. High Vacuum Annealing Furnace, Electro-polishing setup, Centrifugal barrel polishing machine, RF measurement etc.
- Building is ready.

## Lab Building

- Facility being set up: CMM, SIMS, material testing facility, thin film deposition facility etc .

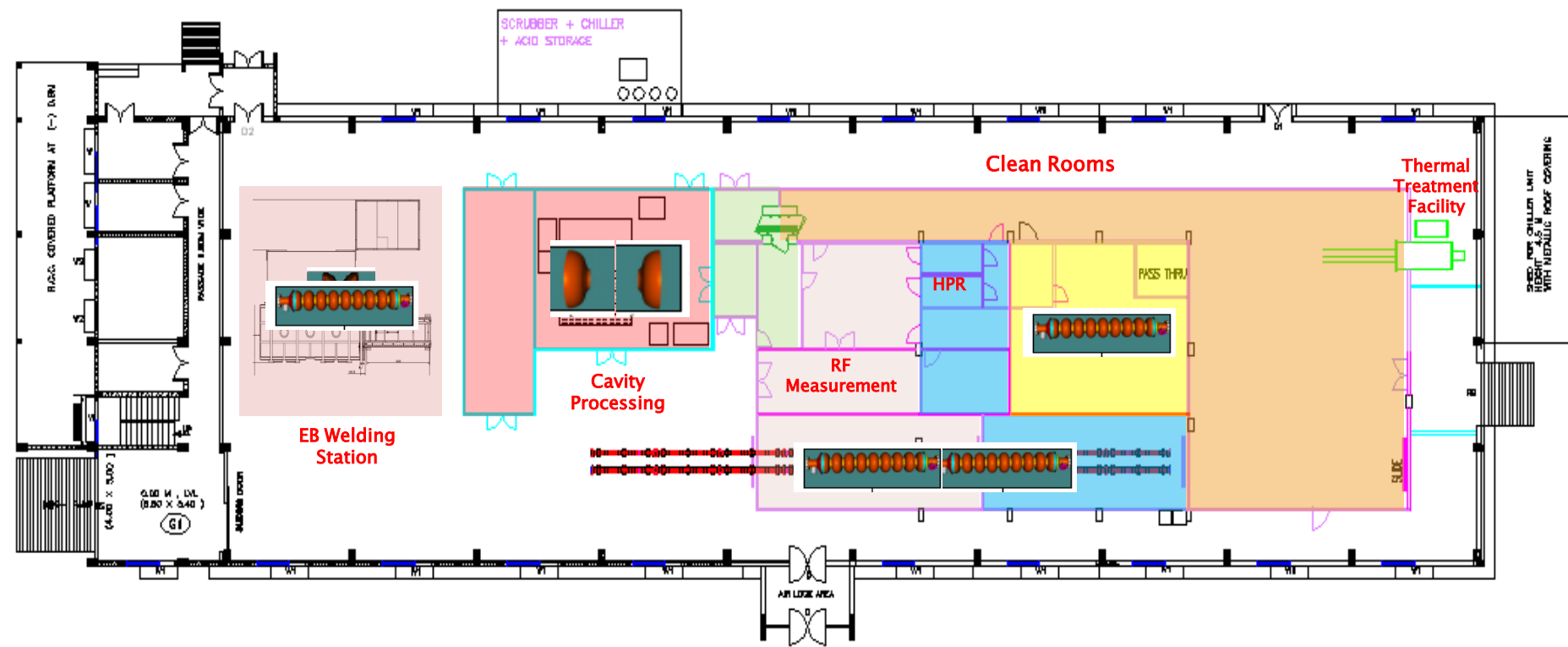


# SCRF Cavity Processing Building (Equipment Layout)



## SCRF Cavity Movement in SCRF Building

After EB welding → To RF Measurement and  
 After string assembly → To Cryomodule Assembly  
 for fabricating superconducting  
 bells Building cell cavity





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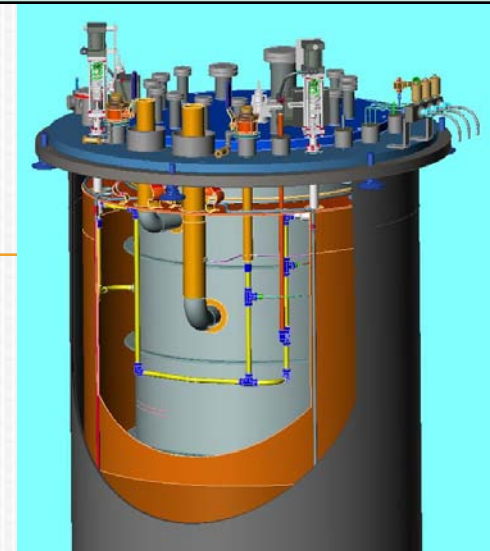
## Cavity testing facility

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## Development of 2K Vertical Test Stand

- ☐ Single & 9-cell Tesla-style cavities (2 – 6 cavities)
- ☐ Single Spoke Resonator cavity 325 MHz
- ☐ Triple Spoke Resonator Cavity 325 MHz
  - Measure Q vs. T ( $T_{\min} \sim 1.5$  K)
  - Measure Q vs.  $E_{\text{acc}}$  at 2 K
- ☐ cryogenic capacity  $\sim 250$  W at 2 K
- ☐ Magnetically shielded cryostat
  - External (room-temperature) Amumetal® (80% Ni alloy) and internal Cryoperm 10® magnetic shield, designed to attenuate field to  $< 10$  mG at cavity
- ☐ Radiation shielding to maintain “Controlled Area” status
  - ☐  $< 5$  mrem in an hour immediately outside the shielding

Outside diameter of Vacuum Vessel + outside magnetic shield	$\leq 58$ inches
Length of Vacuum Vessel (from top flange to crown of head)	211.375 inches
Clear aperture of the Helium Vessel	34 inches
Length of Helium Vessel (from top flange to crown of head)	191.35 inches
80K Shield sits in space between Helium Vessel OD & Vacuum Vessel ID	



Work was taken up under IIFC

## Development of 2K Cryostat for VTS

**RRCAT carried out design of various components of 2K VTS Cryostat:**

- Liquid Helium Vessel
- 80K shield
- Vacuum Vessel
- Top Insert Plate
- Magnetic shielding (2K + room temperature)
- Piping layout for liquid helium
- 3-D model of the complete VTS-2 assembly

Three VTS cryostats are under fabrication at US vendor under joint supervision of engineers from Fermi Lab and RRCAT.

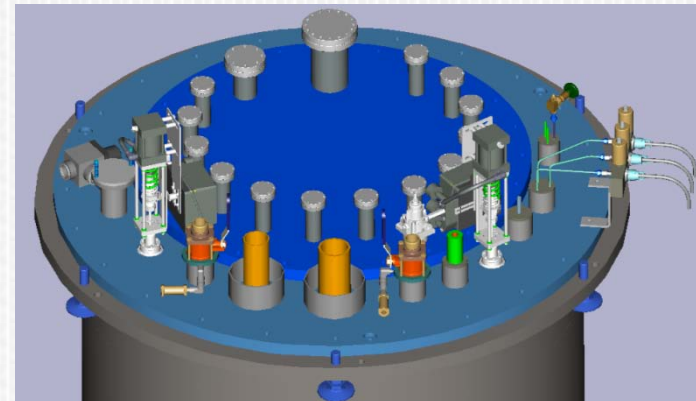
**Expected delivery schedule : March 2012.**

**Building to house VTS at RRCAT is under construction and expected to be ready by December 2011**

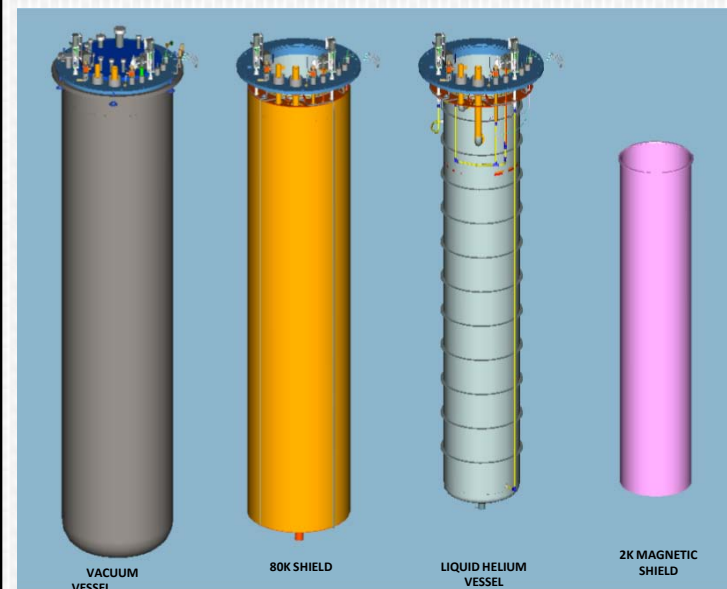
**Cryogenics system under process (P K Kush & Team)**

**Components of RF and DAQ system for RRCAT VTS is under process and expected to be ready by Dec 2011.**

**(P Shrivastava & Team – RF and T A Puntambekar & Team – DAQ)**



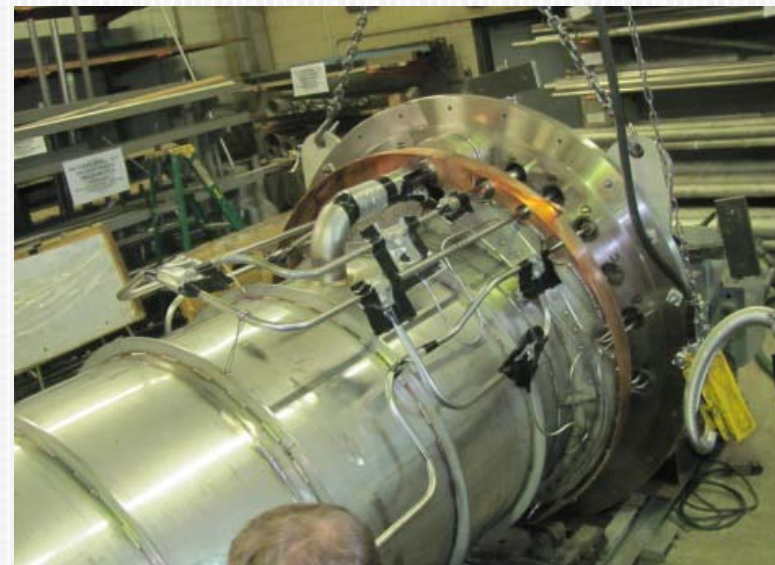
**VTS-2 TOP PLATE – CRYOGENIC & VACUUM INSERTS**



**3-D MODELS OF VTS-2 VESSELS**



# Pictures of VTS under fabrication at manufacturer (in USA)



# Thank You

